

Applicant(s)	Youngner et al.	<p style="text-align: center;"><u>AMENDMENT</u> <u>AND RESPONSE</u> <u>UNDER 37 C.F.R. § 1.116</u> <u>EXPEDITED</u> <u>EXAMINATION</u> <u>PROCEDURE</u></p>
Serial No.	10/712,444	
Filing Date	11/13/2003	
Group Art Unit	1762	
Examiner Name	David P. Turocy	
Confirmation No.	8710	
Attorney Docket No.	H0005690-5601	
Title: THIN FILM DEPOSITION METHODS AND APPARATUSES		

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In response to the Final Office Action mailed on February 27, 2006, please amend the above-identified application as follows.

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks begin on page 9 of this paper.